

**INFORMATION DISCLOSURE CITATION**  
*(Use several sheets if necessary)*
Docket Number (Optional)  
083-06Application Number  
107576327Applicant(s)  
Tetsuya Nakabeppu and Tsutomu TamuraFiling Date  
Herewith

Group Art Unit

NA

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/VC/	AA	WO 2004/048480	06/10/2004	INTERNATIONAL				
/VC/	AB	JP 2002-156521 A	05/31/2002	JAPAN				
/VC/	AC	JP 2001-133624 A	05/18/2001	JAPAN				
/VC/	AD	JP 2002-138203 A	05/14/2002	JAPAN				
/VC/	AE	JP 2002-301785 A	10/15/2002	JAPAN				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*


## EXAMINER

/Vivian Chen/

## DATE CONSIDERED

12/23/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

4-19-2006

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				Applicant(s) Tetsuya Nakabeppu and Tsutomu Tamura			
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FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
							YES
NCI	AF	JP 2002-249721 A	09/06/2002	JAPAN			
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NCI	AH	JP 2004-161792 A	06/10/2004	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER /Vivian Chen/				DATE CONSIDERED		12/23/2007	
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5-11-06

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) 083-06		Application Number 10/576,327	
				Applicant(s) <b>Tetsuya Nakabeppu and Tsutomu Tamura</b>			
				Filing Date <b>April 19, 2006</b>		Group Art Unit <b>NA</b>	
				<b>U.S. PATENT DOCUMENTS</b>			
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/NC/	AA	3,575,871	04/20/1971	Susi, et al.			
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
							YES
/NC/	AB	JP43-25335 B	11/01/1968	JAPAN			NO
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
<b>EXAMINER</b> /Vivian Chen/				<b>DATE CONSIDERED</b> 12/23/2007			
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